

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: ERIC J. BERGMAN

APPLICATION NO.: 10/631,376

FILED: JULY 30, 2003

FOR: **METHODS OF THINNING A SILICON WAFER USING  
HF AND OZONE**

EXAMINER: Z. EL ARINI

ART UNIT: 1746

CONF. NO: 2135

**PETITION FOR A ONE-MONTH EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant petitions for a one-month extension of time in which to respond to the Final Office Action mailed 02/22/2007, extending the period for response to 06/22/2007. Payment of the one-month extension fee of \$120 (large entity) has been electronically submitted.

Dated: June 20, 2007

Respectfully submitted,

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Certificate of Electronic Filing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being electronically filed with the U.S. Patent and Trademark Office on the date entered below.

June 20, 2007  
Date of Electronic Submission

Debbie Gilbert  
Debbie Gilbert